Sheet 1 of 1

Form PTO-1449 (REV. 8-83)	US Dept. of Commer PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 105192.01			APPLICATION NO. 09/722,506	
INFO	RMATION DISCLOSURE STATEMENT				i		
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			FILING I	DATE 128, 2000 124 0 4 2001	GRO	UP 28	75/
FILING DATE November 28, 2000 U.S. PATENT DOCUMENTS GROUP 285							
EXAMINER INITIAL	DOCUMENT NUMBER		DATE	NAME		CLASS	SUB CLASS
72	5,835,285	01-9	8	Matsuzawa et al.		359	754
HN	5,903,400	05-9	9	Endo		359	758
42	5,943,172	08-9	9	Sasaya et al.		359	754
42	5,956,182	09-9	9	Takahashi		359	649
47	6,008,884	12-9	9	Yamaguchi et al.		355	53
HN	6,084,723	07-00		Matsuzawa et al.		359	754
T 7	6,088,171	07-0	0	Kudo		359	754
47	6,104,544	08-0	0	Matsuzawa et al.		359	649
	FORE	IGN PA	TENT DO	CUMENTS			
	DOCUMENT NUMBER	I.	DATE	COUNTRY		CLASS	SUB CLASS
なと	EP-A1-0 828 172	03-98		Europe			
	OTHER DOCUMENTS (I	ncluding	g Author, 7	Title, Date, Pertinent Pages, etc.)			
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Form PTO-1449 US Dept. of Commerce (REV. 8-83) PATENT & TRADEMARK OFFICE		105192.01 Rul		PLICATION NO. le 53(b) Divisional of				
INFORMATION DISCLOSURE STATEMENT						9/234,969 filed January 21, 999		
(Use several sheets if necessary)			APPLICANT(S) Koji SHIGEMATSU					
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	1	U.S. PATI		CUMENTS		28	<u>101</u>	
EXAMINER INITIAL	DOCUMENT NUMBER		DATE	NAME		CLASS	SUB CLASS	
HN	HN 5,437,946)5	Mccoy	<u></u> .	430	5	
	4,948,238	08-9	90	Araki et al.		350	469	
	5,856,883	01-9	9	Sander		358	389	
	5,831,776	11-9	8	Sasaya et al.		359	754	
	5,808,814	09-9	8	Kudo		359	754	
	5,781,278	07-9	8	Matsuzawa et al.		355	53	
	5,623,365	04-9	7	Kuba		359	569	
	5,617,182	04-9	7	Wakamoto et al.		355	53	
	5,555,479	09-9	6	Nakagiri	· · · · · · · · · · · · · · · · · · ·	359	3 <i>5</i> 5	
	5,477,304	12-95	5	Nishi		355	53	
	5,437,946	08-95	5	Mccoy.		430	5	
	4,948,238	08-90	0	Araki et al.		350	469	
	5,930,049	07-99)	Suenaga et al.		359	650	
	5,920,379	07-99)	Matsuyama		327	67	
HN	5,990,926	11-99	Mercado		347	258.		
	FORE	EIGN PAT	TENT DO	OCUMENTS				
	DOCUMENT NUMBER		ATE	TE COUNTRY		CLASS	SUB CLASS	
HN	JP-7-140385	06-95		Japan				
	EP-A2-732 605	09-96		Europe				
	JP-7-128592	05-95		Japan				
HN	JP-5-034593	01-93		Japan				
T	OTHER DOCUMENTS (I	ncluding A	Author,	Title, Date, Pertinent Pages, etc.)				
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(Use several sheets if necessary)			APPLICANT(S) Koji SHIGEMATSU						
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	U.	S. PAT	ENT DOC	UMENTS		т			
EXAMINER INITIAL	DOCUMENT NUMBER	i	DATE	NAME		CLASS	SUB CLASS		
HN	5,781,278	07-	-98	Matsuzawa et al.		355	5 53		
	5,717,518	02	-98	Shafer et al.			357		
	5,636,000	06-97 12-95		Ushida et al.	.	322_	30		
	5,473,410			Nishi		355	53		
	5,392,094	02	-95	Kudo			0		
	5,307,207	04	-94	Ichihara			8		
	5,260,832	11-	-93	Togino et al.		2			
	5,237,367	08-93		Kudo		-50			
	5,172,275	12-92		DeJager		349	755		
	5,170,207	12	-92	Tezuka et al.		355	53		
	5,105,075	04	-92	Ohta		250	201.2		
	4,939,630	07	-90	Kikuchi et al.		362	268		
HN	4,931,830	06-90		Suwa et al.		355	71		
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	DOCUMENT NUMBER		DATE	COUNTRY		CLASS	SUB CLASS		
HN	EP-A2-803 755	10-97		Europe					
	EP-A2-770 895	05	- 97	Europe					
	EP-A2-733 605	09	-96	Europe					
	EP-A2-721 150	07	-96	Europe			-		
HW	EP-A1-717 299	06	-96	Europe					
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HN	"Quality of Microlithographic Proje Technology for Integrated Circuit F	ection l abrica	Lenses" by tion and In	J. Braat, SPIE Proceedings, vol. 8 spection, H. Stover, S. Wittekoek,	11, Optica Eds, pp.	l Microlithog 22-30 (April	graphic 1987)		
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